



Attorney Docket No. 0756-7295

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Koichiro TANAKA

Serial No. 10/827,402

Filed: April 20, 2004

For: BEAM IRRADIATION APPARATUS,
BEAM IRRADIATION METHOD, AND
METHOD FOR MANUFACTURING
THIN FILM TRANSISTOR

) Group Art Unit: 2891

) Examiner: Bradley Smith

) CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on November 8, 2007.

Richard M. Stamper

AMENDMENT

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Official Action dated August 8, 2007, please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.